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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Cho et al.

Atty Docket No.: NOVLP089/NVLS-

002886/002887

Application No.: 10/800,377

Examiner: Not yet assigned

Filed: March 11, 2004

Group: 2812

Title: METHOD AND APPARATUS FOR UV EXPOSURE OF LOW DIELECTRIC CONSTANT MATERIALS FOR POROGEN REMOVAL AND IMPROVED MECHANICAL PROPERTIES

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on September 28, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria VA 22313 1450.

Signed:

Tara Hayden

REQUEST FOR STATUS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant hereby requests status of the above-referenced patent application. This application was filed on March 11, 2004 and no response has been received as of this date.

Respectfully submitted,

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